

Application/Control No.	Applicant(s)/Patent under Reexamination	_
10/631,836	KIM, JOON TAE	
Examiner	Art Unit	_
Sherrie Hsia	2622	

Sherrie Hsia

	SEARCHED				
Class	Subclass	Date	Examiner		
348	614, 607, 624, 914	4/06	SM		
375	229, 232,				
	286, 346				
	260				
H04N	5/21				
	5/213				

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
	1					

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST	4/06	54		